



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** Ricky S. Amos, et al.

**Examiner:** Asok K. Sarkar

**Serial No:** 10/786,901

**Art Unit:** 2891

**Filed:** February 25, 2004

**Docket:** YOR920030334US1 (16899)

**For:** CMOS SILICIDE METAL GATE  
INTEGRATION

**Dated:** January 9, 2006

**Confirmation No. 6726**

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action dated September 9, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

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**FIRST CLASS MAIL CERTIFICATION**

I hereby certify that I am mailing the attached documents to the Commissioner for Patents on the date specified, in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, and First Class Mailed under the provisions of 37 CFR 1.8.

**Dated:** January 9, 2006

  
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Leslie S. Szivos, Ph.D.